



Inventor: *Sam Basceri et al.*

Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate
Comprising Dielectric Layers

Assignee: Micron Technology, Inc.

Serial No: 09/905286
Filed 7/13/01

INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether any of the submitted references is prior art. Copies of the references are attached.

Respectfully submitted, **RECEIVED**
AUG 02 2002
TC 1700

Dated:

July 29, 2002

Attorney:

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